

Notice of References Cited

Application/Control No.

10/521,453

Applicant(s)/Patent Under
Reexamination
MARUYAMA ET AL.

Examiner

DANIEL C. MCCracken

Art Unit

1793

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,919,064	07-2005	Resasco et al.	423/447.3
*	B	US-6,761,870	07-2004	Smalley et al.	423/447.3
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Dresselhaus, et al., Science of fullerenes and carbon nanotubes 756-776 (Academic Press 1996)
	V	Choi, et al., Controlling the diameter, growth rate, and density of vertically aligned carbon nanotubes synthesized by microwave plasma-enhanced chemical vapor deposition, Applied Physics Letters 2000; 76(17): 2367-2369
	W	Bower, et al., Nucleation and growth of carbon nanotubes by microwave plasma chemical vapor deposition, Applied Physics Letters 2000; 77(17): 2767-2769
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.